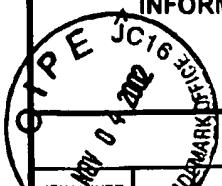


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2185

U.S. PATENT DOCUMENTS

EXAMINER INITIATOR	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
Elek	5,991,737	11/23/99	Chen	705	26	
	5,918,223	6/29/99	Blum et al.	707	1	
	5,842,162	11/24/98	Fineberg	704	223	
	5,787,334	7/28/98	Fardeau et al.	455	2	
	5,581,800	12/3/96	Fardeau et al.	455	2	
	5,581,658	12/3/96	O'Hagan et al.	395	22	
	5,577,249	11/19/96	Califano	395	61	RECEIVED
	5,574,962	11/12/96	Fardeau et al.	455	2	NOV 05 2002
	5,437,050	7/25/95	Lamb et al.	455	2	Technology Center 2100
	5,210,820	5/11/93	Kenyon	395	2	
✓	5,134,719	7/28/92	Mankovitz	455	154.1	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
Elek	EP 0 982 578 A2	03/01/2000	EP	G01M 13	02	✓	
	WO 97/40491	10/30/97	PCT	G10L 5	06	✓	
	WO 97/33273	9/12/97	PCT	G10L 5	06	✓	
	EP 0 480 010 B1	9/11/96	EP	G10L 5	06	✓	
✓	WO 94/00842	01/06/94	PCT	G11B 17	22	✓	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

EP Fardeau

DATE CONSIDERED

9/27/04

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